IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

cants:

R.B. Darling et al.

Attorney Docket No.: UWOTL116278

Application No.: 09/744,360

Group Art Unit: 3653

Filed:

January 22, 2001

Examiner: T.N. Nguyen

Title:

CHARGED PARTICLE BEAM DETECTION SYSTEM

RECEIVED GROUP 3600

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

August 15, 2003

TO THE COMMISSIONER FOR PATENTS:

Applicants are aware of the information listed in the attached form that may be material to the prosecution of the above-identified patent application.

- Copies of the listed patents, publications, and other information are enclosed for the Examiner's use.
- Pursuant to 37 C.F.R. § 1.97(b), this Information Disclosure Statement is being \mathbf{X} filed within three months of the filing date of the national application (other than a CPA), within three months of the date of entry of the national stage as set forth in 37 C.F.R. § 1.491 in an international application, before the mailing date of a first Office Action on the merits, or before the mailing date of a first Office Action after the filing of an RCE.

Respectfully submitted,

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I hereby certify that this correspondence is being deposited with the U.S. Postal Service in a sealed envelope as first class mail with postage thereon fully prepaid and addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the below date.

GER:md

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INFORMATION CITED BY APPLICANTS THAT MAY BE MATERIAL TO THE PROSECUTION OF THE SUBJECT APPLICATION

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Title:		CHARGED PARTICLE BEAM DETECTION SYSTEM					AUG 2 1 2003	
U.S. PATENT DOCUMENTS							GROUP 36	
*Examiner Initials	Cite No.	Document No.	Kir Coo		Date (mm/dd/yyyy)	Name		
	U5	4,724,324			02/09/1988	Liebert		
FOREIGN PATENT DOCUMENTS								
*Examiner (Cite No.	Document No.	Kind Code		ication Date m/dd/yyyy)	Country	English Abstract Translation Provided Provided	
NON	IE							
OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)								
*Examiner Initial	Cite No.							
·	O1 Natsuaki, N., et al., "Spatial Dose Uniformity Monitor for Electrically Scanned Ion Beam," <i>Rev. Sci. Instrum.</i> 49(9):1300-1304, September 1978.							
	O2 O'Morain, C., et al., "Large-Diameter Plasma Profile Monitoring System Using Faraday Cup and Langmuir Probe Arrays," <i>Meas. Sci. Technol.</i> 4:1484-1488, December 1993.							
	O3 Scheidemann, A.A. et al., "Linear Dispersion Mass Spectrometer," Proceedings of the 47th American Society for Mass Spectrometry Conference on Mass Spectrometry and Allied Topics, Dallas, Texas, June 1999.							
Examiner		Date Considered						

*Examiner: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicants.

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